

**PATENT APPLICATION**

**RESPONSE UNDER 37 CFR §1.116  
EXPEDITED PROCEDURE  
TECHNOLOGY CENTER ART UNIT 2814**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Hiroshi ISHIYAMA

Group Art Unit: 2814

Application No.: 10/778,029

Examiner: G. PERALTA

Filed: February 17, 2004

Docket No.: 118695

For: SEMICONDUCTOR MODULE HAVING INNER PRESSURE RELEASE PORTION

**AMENDMENT AFTER FINAL REJECTION UNDER 37 CFR §1.116**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

*Interf w/ KCE*  
*UMB*  
*6/1/04*

Sir:

In reply to the November 15, 2005 Office Action, please consider the following:

**Amendments to the Claims** as reflected in the listing of claims; and

**Remarks.**